



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449**

Docket No. 52433/850	Application No. 10/582,123	
Applicant(s) NOMURA et al.	Examiner Michael A. Lavilla	
Filing Date June 7, 2006	Confirmation No. 1778	Art Unit 1794

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/ML/	JP 2001-225008 A	August 21, 2001	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER /Michael LaVilla/ DATE CONSIDERED 06/25/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449**

Docket No. 52433/850	Application No. 10/582,123	
Applicant(s) NOMURA et al.	Examiner Michael A. Lavilla	
Filing Date June 7, 2006	Confirmation No. 1778	Art Unit 1794

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	JP 2001-225008 A	August 21, 2001	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER	/Michael LaVilla/	DATE CONSIDERED	06/25/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			